

Substitute for form 1449/PTO

**INFORMATION DISCLOSURE
STATEMENT BY APPLICANT**

(use as many sheets as necessary)

Complete If Known

Application Number	10/541,145
Filing Date	June 29, 2005
First Named Inventor	Tobias Schmidt
Art Unit	1743
Examiner Name	Jan M. Ludlow
Attorney Docket Number	P&P-101

Sheet	1	of	2
-------	---	----	---

NON PATENT LITERATURE DOCUMENTS

Examiner Initials*	Cite No. 1	Include name of the author (in CAPITAL LETTERS), title of the article, (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T ²
	R1	FEUSTEL, A. et al., "A Micro Mass Spectrometer," <i>Sensor Kongressband</i> , 1995, pages 465-470.	
	R2	FEUSTEL, A. et al., "A Microsystem Mass Spectrometer," <i>Micro Total Analysis Systems</i> , 1994, pages 299-304.	
	R3	GREVESMÜHL, B. "Miniaturisierte Gaschromatographie-Module verbessern Prozesse in der Chemie," <i>P&A Kompendium</i> , 2005/2006, pages 164-165	
	R4	LEHMANN, U., "Analysis in miniature," <i>Vacuum Solutions</i> , November/December 1998, pages 13-15.	
	R5	LEHMANN, U., "Autarky Gas Chromatographic System Realized in MEMS Technology on a Credit Card-Sized Board," <i>Abstracts Pittcon</i> , 2005, 180-9.	
	R6	LEHMANN, U., "Kleinste Flüsse messen," <i>Journal Forschung und Entwicklung</i> , Heft 6, 2002, Vol. 44, pages 32-35.	
	R7	LEHMANN, U. et al., "A micro gas chromatograph based on a plasma polymerized siliconorganic stationary phase," <i>Sensor Kongressband II</i> , 1997, pages 151-153.	
	R8	LEHMANN, U. et al., "Micro machined analytical gas chromatograph with a plasma polymerised stationary phase," <i>Sensor Proceedings II</i> , 2001, pages 487-492.	
	R9	LEHMANN, U. et al., "Micro machined gas chromatograph based on a plasma polymerised stationary phase," <i>Micro Total Analysis Systems</i> , 2000, pages 167-170.	
	R10	LEHMANN, U. et al., "Mikrogaschromatograph basierend auf einer plasmapolymersierten siliziumorganischen stationären Phase," <i>Jahrg.</i> , 1999, Vol. 53, No. 7, pages 47-49	

Examiner Signature	Date Considered
--------------------	-----------------

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

¹ Applicant's unique citation designation number (optional). ² Applicant is to place a check mark here if English language Translation is attached.

This collection of information is required by 37 CFR 1.98. The information is required to obtain or retain a benefit by the public which is to file (and by the USPTO to process) an application. Confidentiality is governed by 35 U.S.C. 122 and 37 CFR 1.14. This collection is estimated to take 2 hours to complete, including gathering, preparing, and submitting the completed application form to the USPTO. Time will vary depending upon the individual case. Any comments on the amount of time you require to complete this form and/or suggestions for reducing this burden, should be sent to the Chief Information Officer, U.S. Patent and Trademark Office, P.O. Box 1450, Alexandria, VA 22313-1450. DO NOT SEND FEES OR COMPLETED FORMS TO THIS ADDRESS. **SEND TO:** Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450

If you need assistance in completing the form, call 1-800-PTO-9199 (1-800-786-9199) and select option 2.

Substitute for form 1449/PTO

**INFORMATION DISCLOSURE
STATEMENT BY APPLICANT**

(use as many sheets as necessary)

Sheet 2 of 2

Complete If Known

Application Number	10/541,145
Filing Date	June 29, 2005
First Named Inventor	Tobias Schmidt
Art Unit	1743
Examiner Name	Jan M. Ludlow
Attorney Docket Number	P&P-101

NON PATENT LITERATURE DOCUMENTS

Examiner Initials*	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article, (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T ²
	R11	LEHMANN, U. et al., "A Miniaturised Gas Chromatographic Module on a Credit Card Sized Motherboard," <i>Sensor Proceedings</i> , 2003, pages 157-161.	
	R12	LEHMANN, U. et al., "A miniaturized gas chromatograph for autonomous and longtime measurements," <i>Sensor Proceedings I</i> , 1999, pages 155-158.	
	R13	LEHMANN, U., "A Packed Column Realized on a 1 cm ² Sized Silicon Glass Chip for Permanent Gas Separation," <i>Abstracts Pitcon</i> , 2005, 1910-5P.	
	R14	LEHMANN, U., "World's Smallest, Self-Sufficient Gas Chromatography Module from SLS Micro Technology," <i>Abstracts Pitcon</i> , 2004, 1100-100.	
	R15	"Small is Beautiful," <i>The Column</i> , July 2005, pages 22-23.	
	R16	PETZOLD, G. et al., "A Micro Mass Spectrometer," <i>Micro Total Analysis Systems</i> , 2001, pages 224-226.	
	R17	SIEBERT, P. et al., "Processing of Complex Microsystems: A Micro Mass Spectrometer," <i>Symposium on Design, Test, and Microfabrication of MEMS and MOEMS</i> , March-April 1999, Vol. 3580, pages 562-571, Paris, France.	
	R18	SIEBERT, P. et al., "Surface microstructure/miniature mass spectrometer: processing and applications," <i>Appl. Phys. A</i> , 1998, Vol. 67, pages 155-160.	
	R19		
	R20		

Examiner Signature	Date Considered
--------------------	-----------------

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

¹ Applicant's unique citation designation number (optional) ² Applicant is to place a check mark here if English language Translation is attached
This collection of information is required by 37 CFR 1.95. The information is required to obtain or retain a benefit by the public which is to file (and by the USPTO to process) an application. Confidentiality is governed by 35 U.S.C. 122 and 37 CFR 1.14. This collection is estimated to take 2 hours to complete, including gathering, preparing, and submitting the completed application form to the USPTO. Time will vary depending upon the individual case. Any comments on the amount of time you require to complete this form and/or suggestions for reducing this burden, should be sent to the Chief Information Officer, U.S. Patent and Trademark Office, P.O. Box 1460, Alexandria, VA 22313-1450. DO NOT SEND FEES OR COMPLETED FORMS TO THIS ADDRESS. SEND TO: Commissioner for Patents, P.O. Box 1460, Alexandria, VA 22313-1450

If you need assistance in completing the form, call 1-800-PTO-9199 (1-800-786-9199) and select option 2.